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Optimization of azimuthal uniformity of thermal conductance between Al TMP and Si cooling arms

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Optimization of azimuthal uniformity of thermal conductance between Al TMP and Si cooling arms

Presentation at the
19th Target Fabrication Meeting
Feb 23rd, 2010

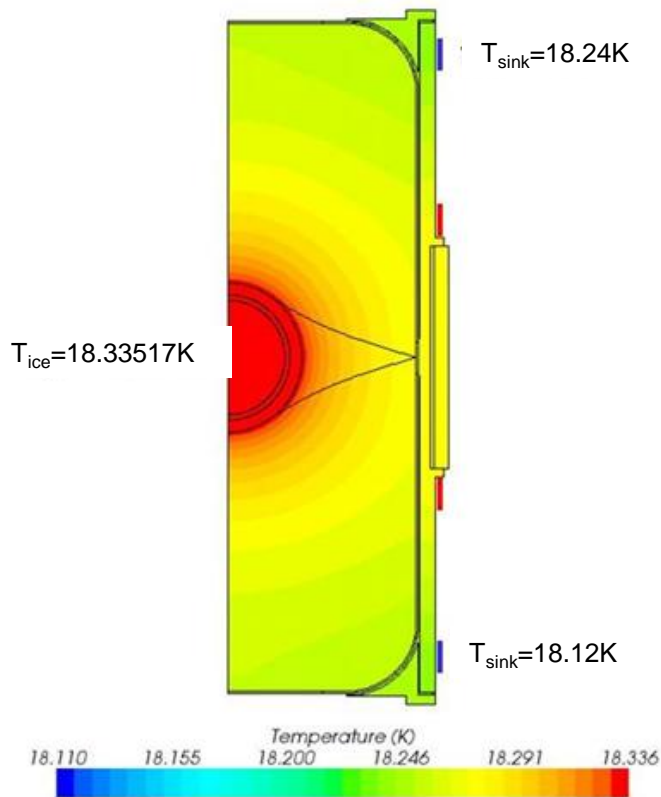
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Evan Mapoles, Jeremy Kroll, John Taylor, Ben Haid, Jim Sater, Jeff Klingmann, Carlos Castro, LLNL
Abbas Nikroo, GA

Lawrence Livermore National Laboratory • National Ignition Campaign

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Cryogenic considerations dominate many aspects of the target design & materials

Simulation of thermal symmetry required at 18K



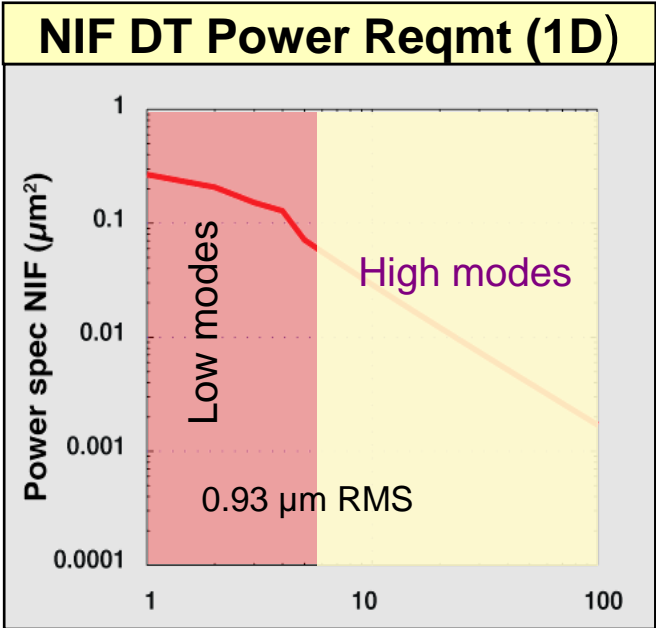
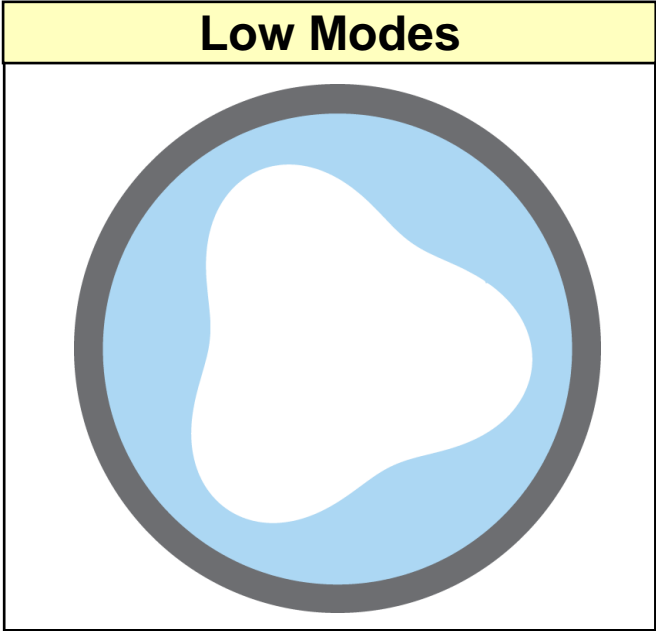
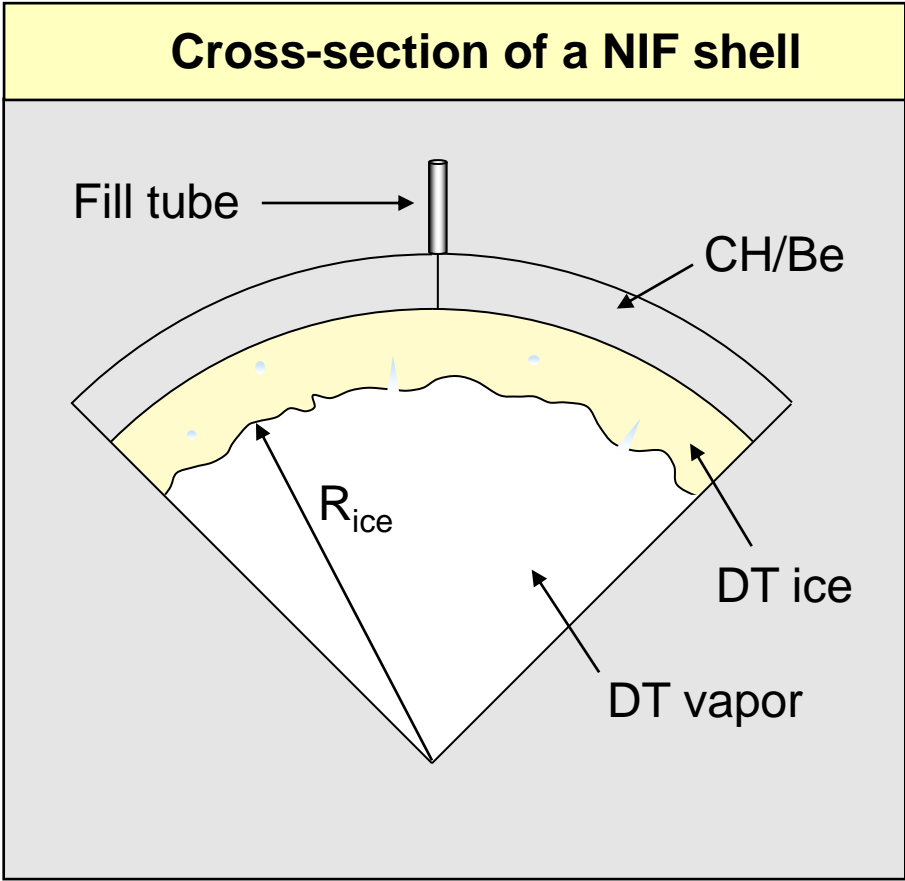
Requirement for low mode roundness: ± 0.5 mK

Cryogenic issues at 18K

- *Thermal impedance between the hohlraum (TMP) and cooling arms*
- He/H₂ flow through capillary fill-tubes (Thurs AM)
- Visco-elastic thin films: windows and tents (Thurs and Fri AM)
- High degree of density control of tamping gas (He or H₂) in the TMP
 - Leak tight

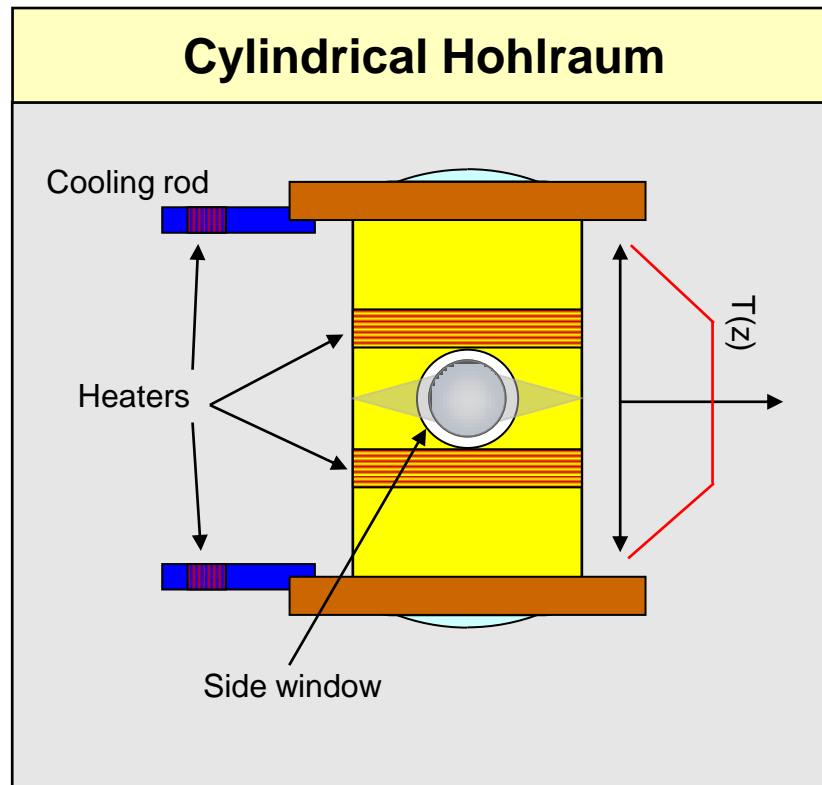
Hydrogen ice layers are critically dependent on cryogenic performance of the target

Ice layer specs



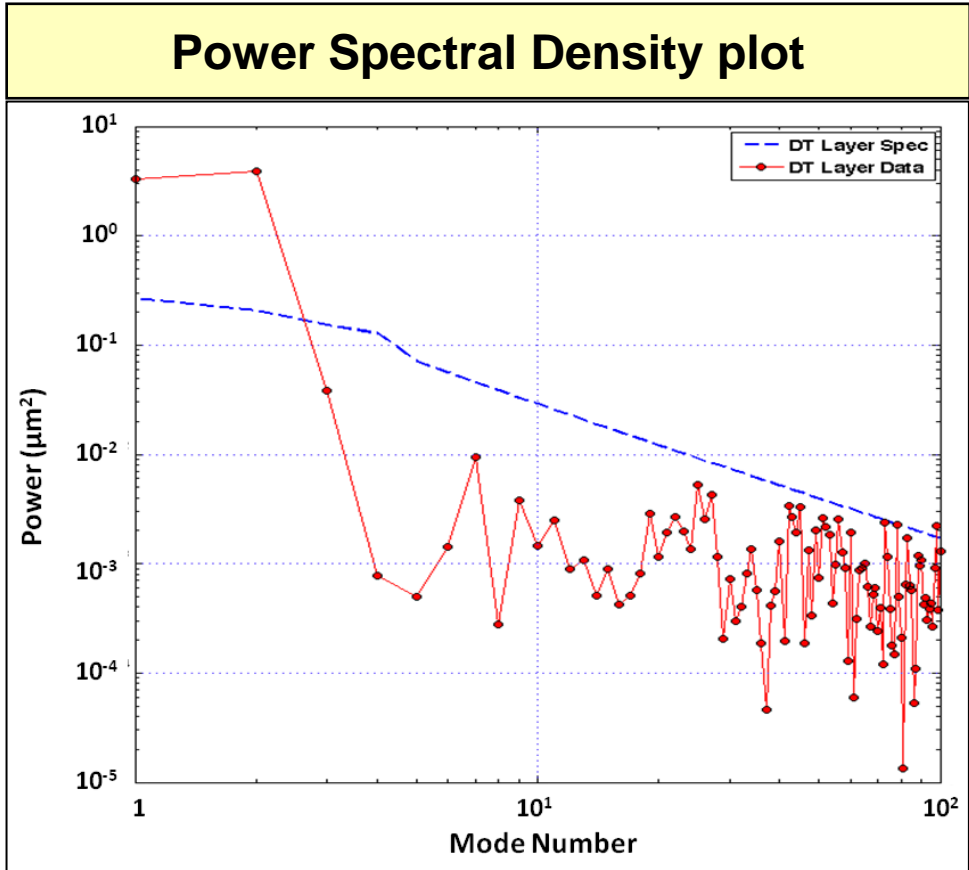
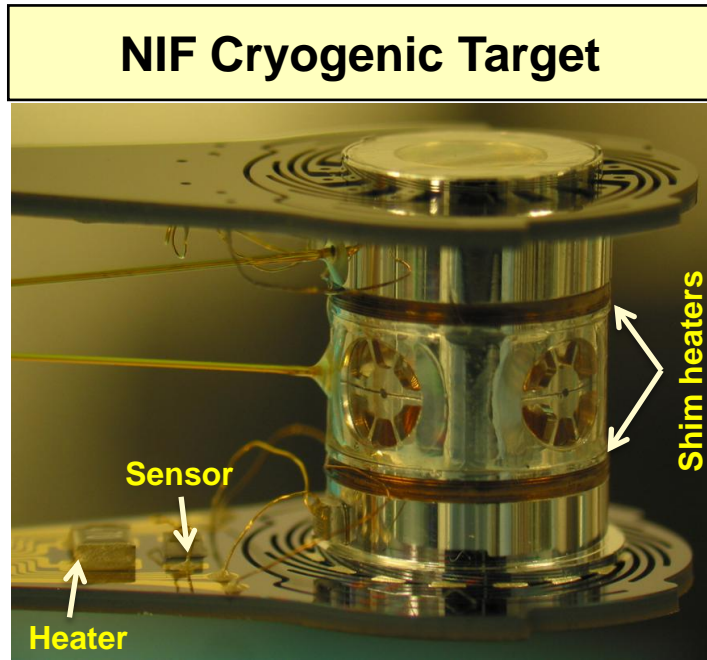
Requirements and tolerances for the ice layer are specified as a power spectral density

'Shimming' heaters are used to create a thermally spherical hohlraum



- Cylindrical configuration leads to capsule being cooler in the mid-plane relative to the ends
 - This makes a layer that is thicker on the equator than the poles.
- Heat the center using heaters: "shimming" to generate spherical thermal profile
- This depends
 - on conductivity of the adhesive
 - on conductivity of the TMP
 - conductivity of the bond between the Si cooling arm and the TMP

Layers met the high mode spec in target R5

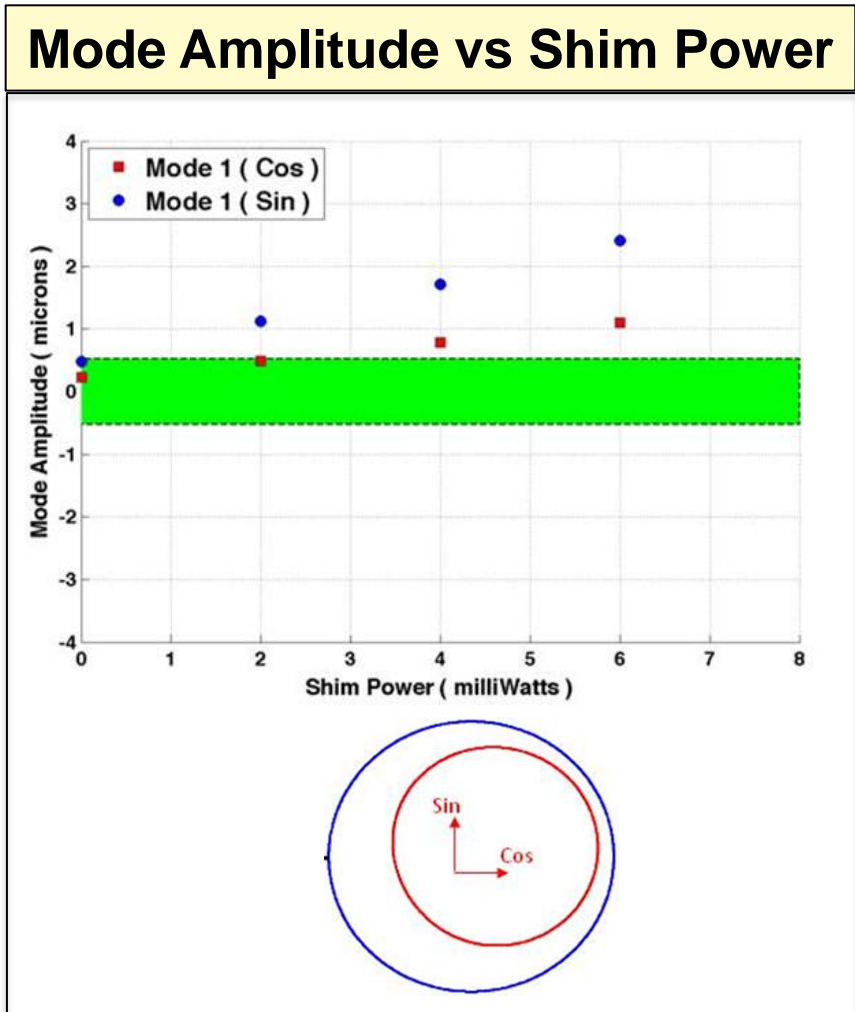
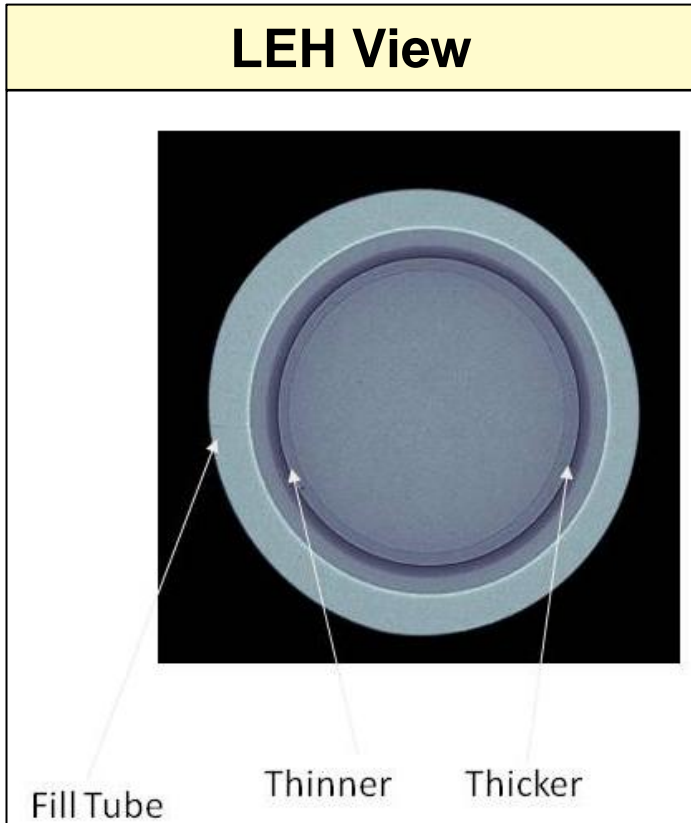


- Si used for its high conductivity (4000 W/mK) and brittleness at shot time
 - Deep RIE fabrication
- Flexures accommodate difference in thermal contraction (0.4% vs 0.02%)

Layers were smooth enough to meet the high mode spec

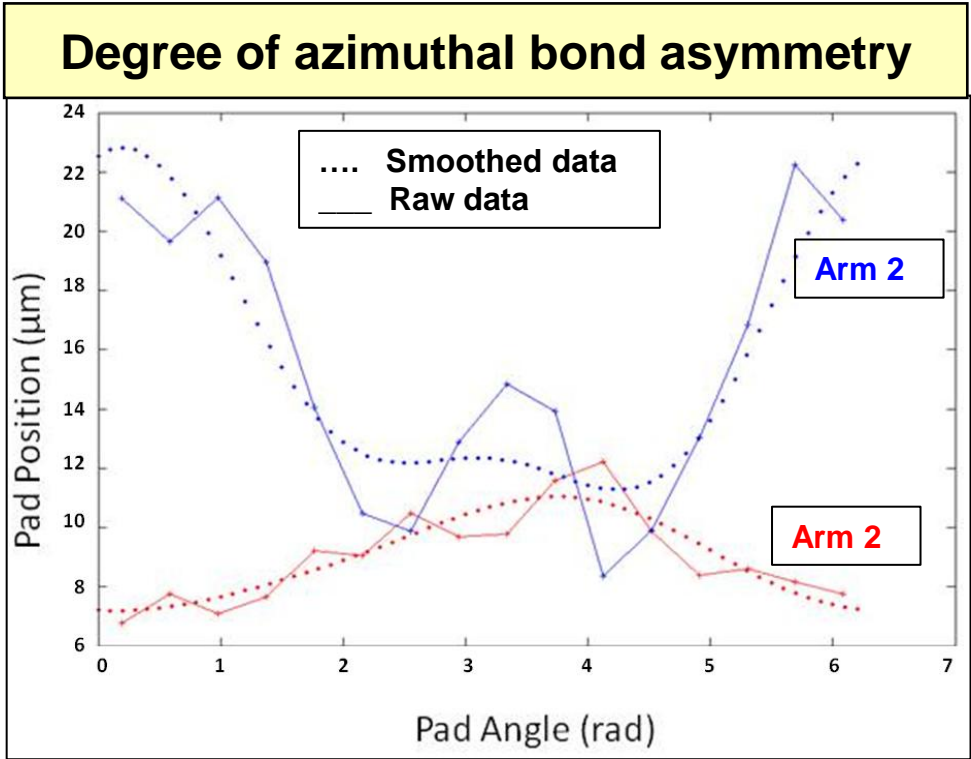
Early prototype targets showed de-centering of the ice layer with shimming power

De-centering of the ice layer occurs as the power required to shim mode P2 is supplied to the shimming heaters



De-centering is a result of azimuthal thermal asymmetry

Prototype layering target bond line thickness data

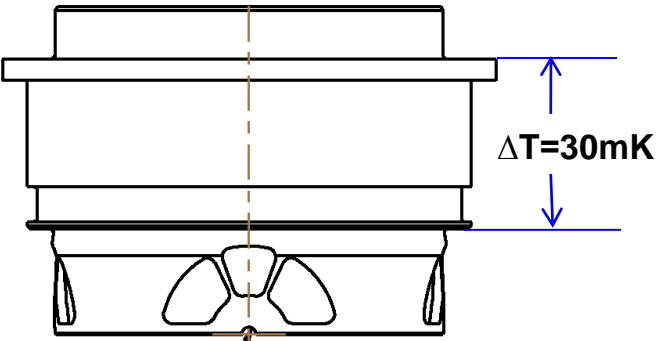


Wedge analysis predicted a de-centering drift towards the fill tube with 34 degree off axis component

Actual drift was towards the fill tube with 16 degree off axis component

FEA thermal model of the TMP

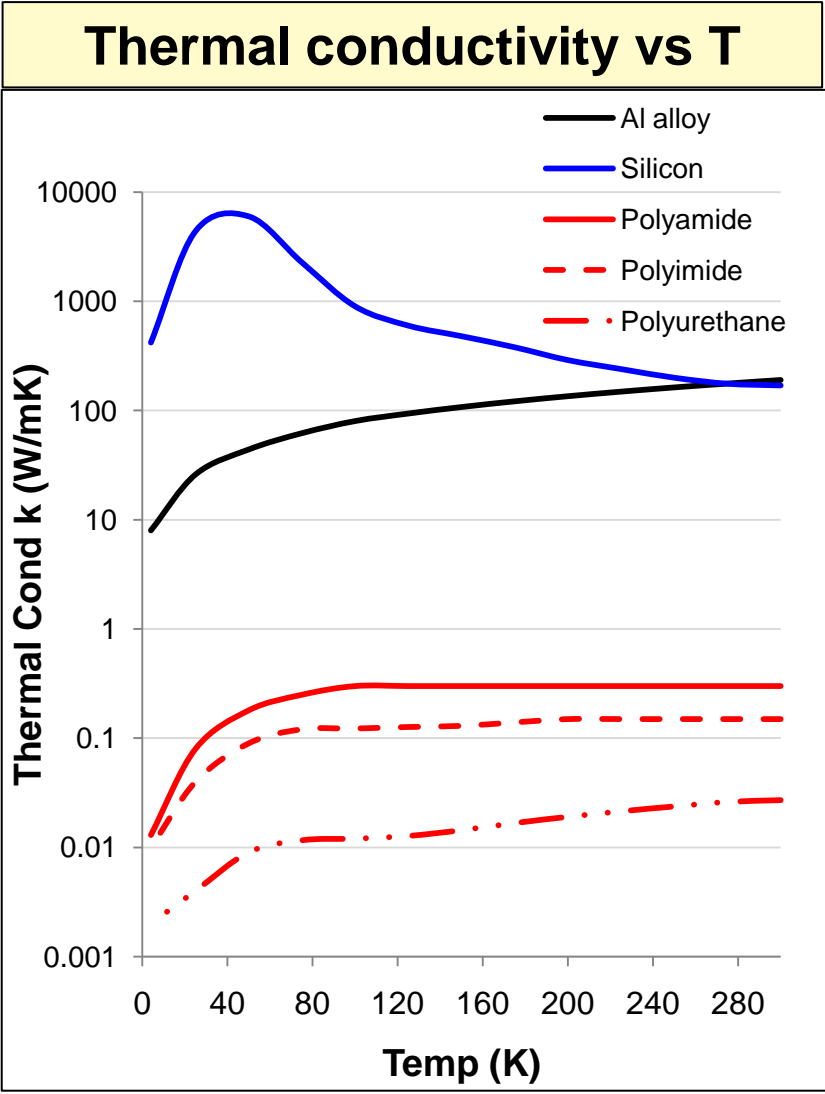
- Requirement: 0.5 mK axisymmetry for low mode roundness



Using $k_{\text{glue}} = 0.1 \text{ W/mK}$ &

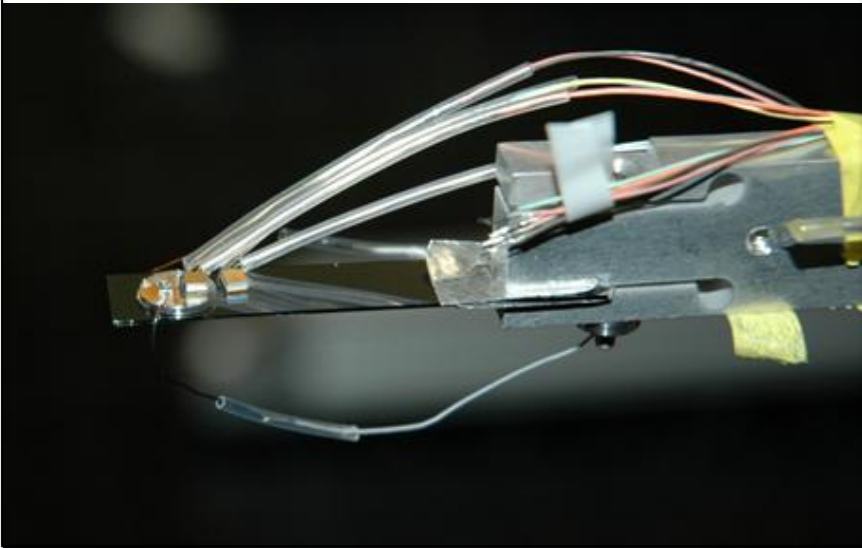
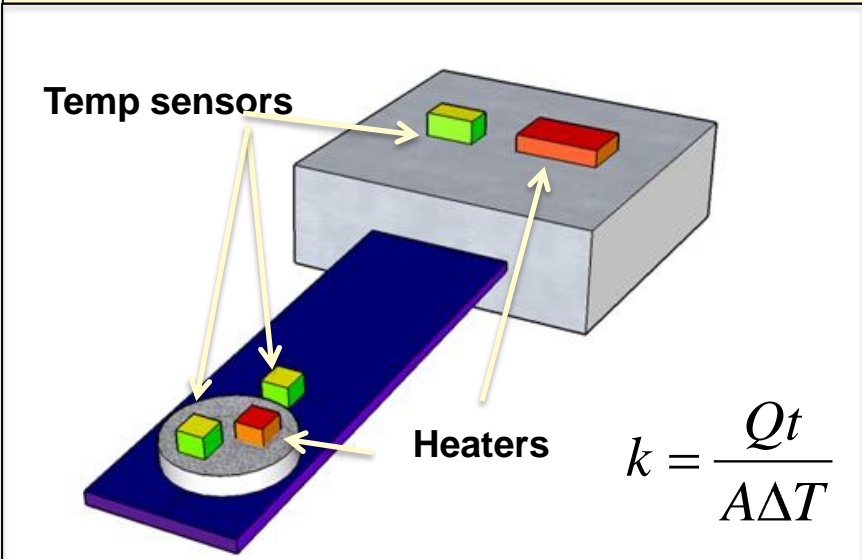
$$k_{\text{Al5052}} = 20 \text{ W/mK}$$

- $\Delta T = 1.8 \text{ mK}$ for PV $\Delta t = 0.2 \mu\text{m}$
- $\Delta T = 0.5 \text{ mK}$ for PV $\Delta t = 0.1 \mu\text{m}$
- $\Delta T = 0.25 \text{ mK}$ for PV $\Delta t = 0 \mu\text{m}$
- Centering : $\pm 5 \mu\text{m}$

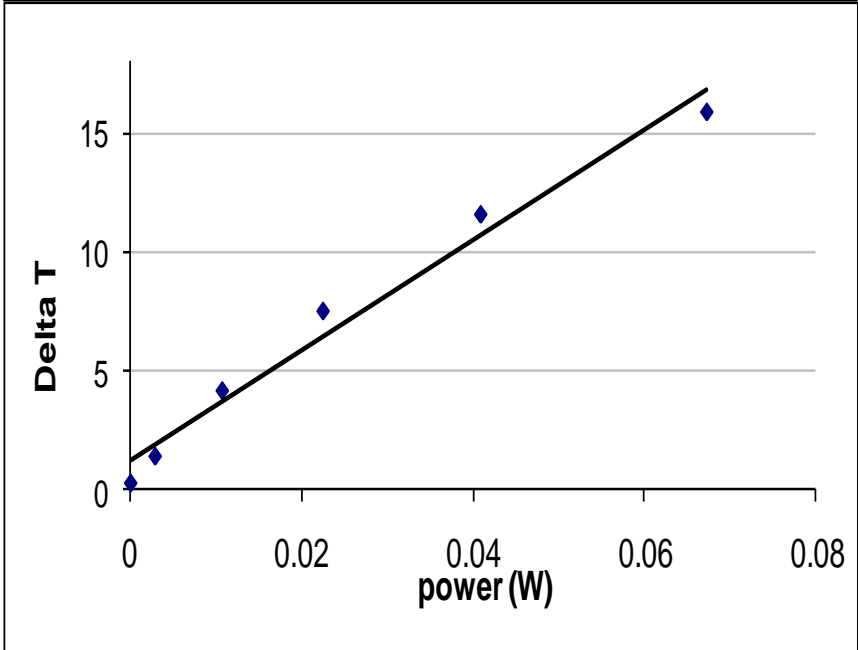


Thermal conductivity measurements @18K

Experimental set-up



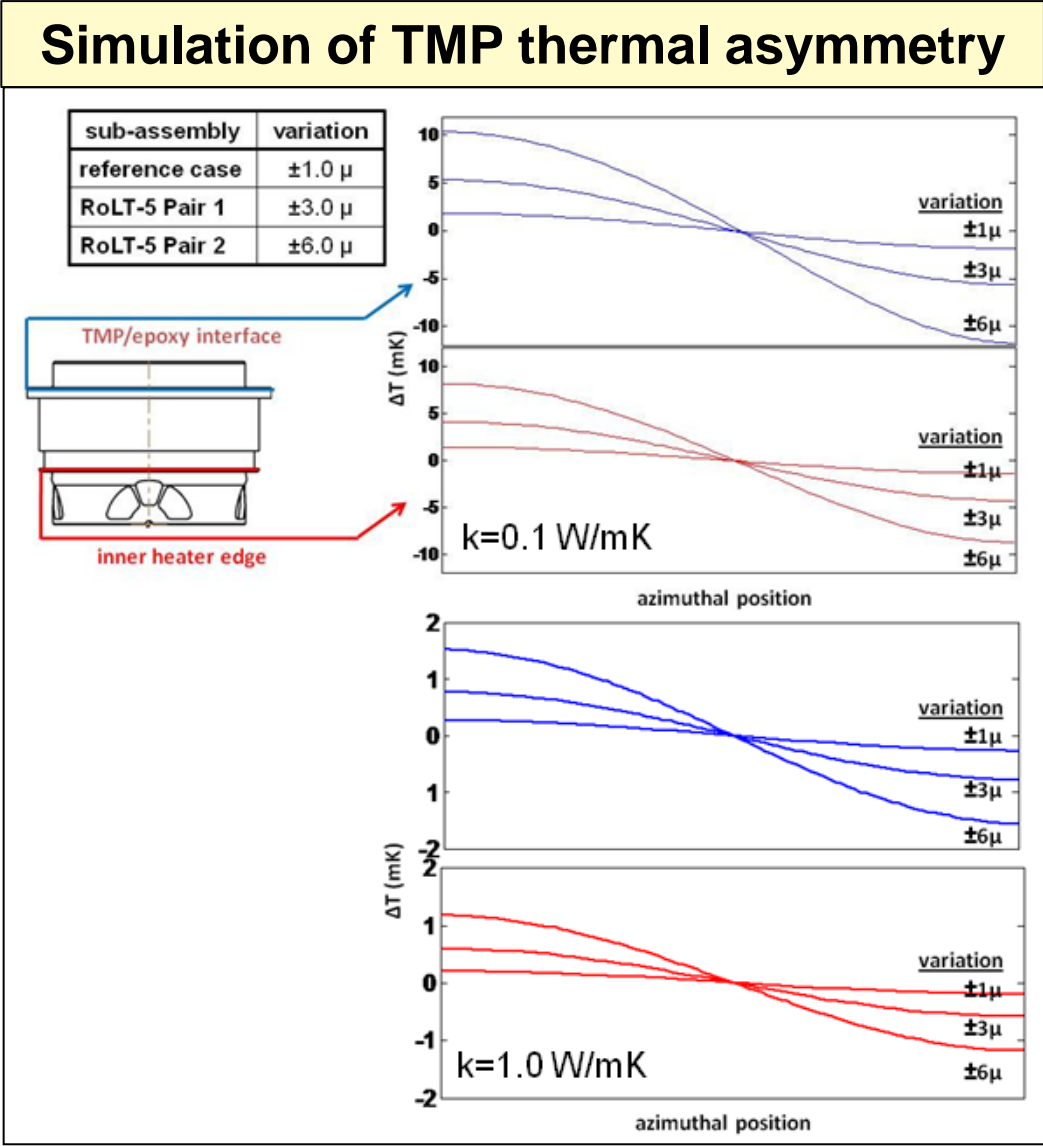
Delta T vs Heater Power



$k_{18K} = 0.006 \text{ W/mK}$

k was an order of magnitude smaller than expected

Role of the thermal conductivity of the adhesive



Glue thermal conductivity, k_{glue} , needs to be increased \rightarrow composite adhesive

Interplay between thermal conductivity and thickness requirements

Need to improve thickness control and conductivity

Single phase adhesive

- $k \sim 0.006$ W/mK
- Thickness control has to be submicron

Composite adhesive

- Expect higher k
- Expect higher viscosity
- Particle size - submicron

Squeeze flow

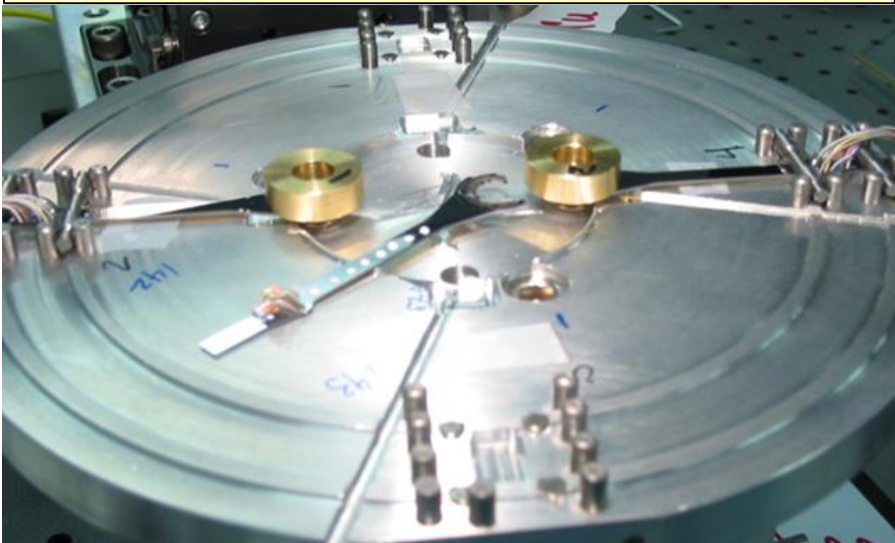
- Could be used with a higher viscosity adhesive
- Depends on surface tension and to some extent on viscosity

Uniformity by fixing the gap

- Machined bump on the TMP flange
- Allow the adhesive to wick in after dry alignment

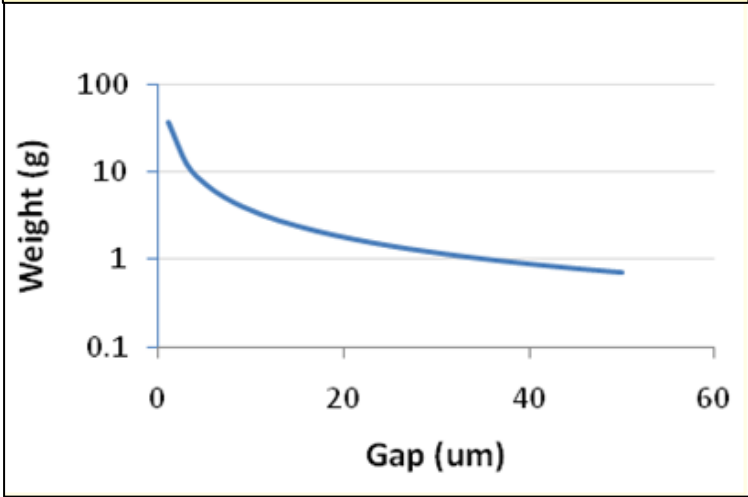
Thickness control using squeezing flow

Force applied is limited by silicon arm toughness

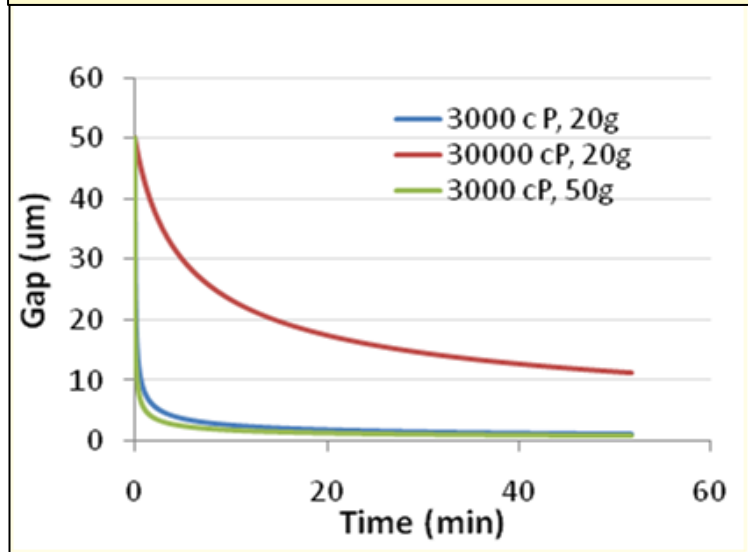


Viscosity should be <10,000 cP

Gap due glue vs force (model)

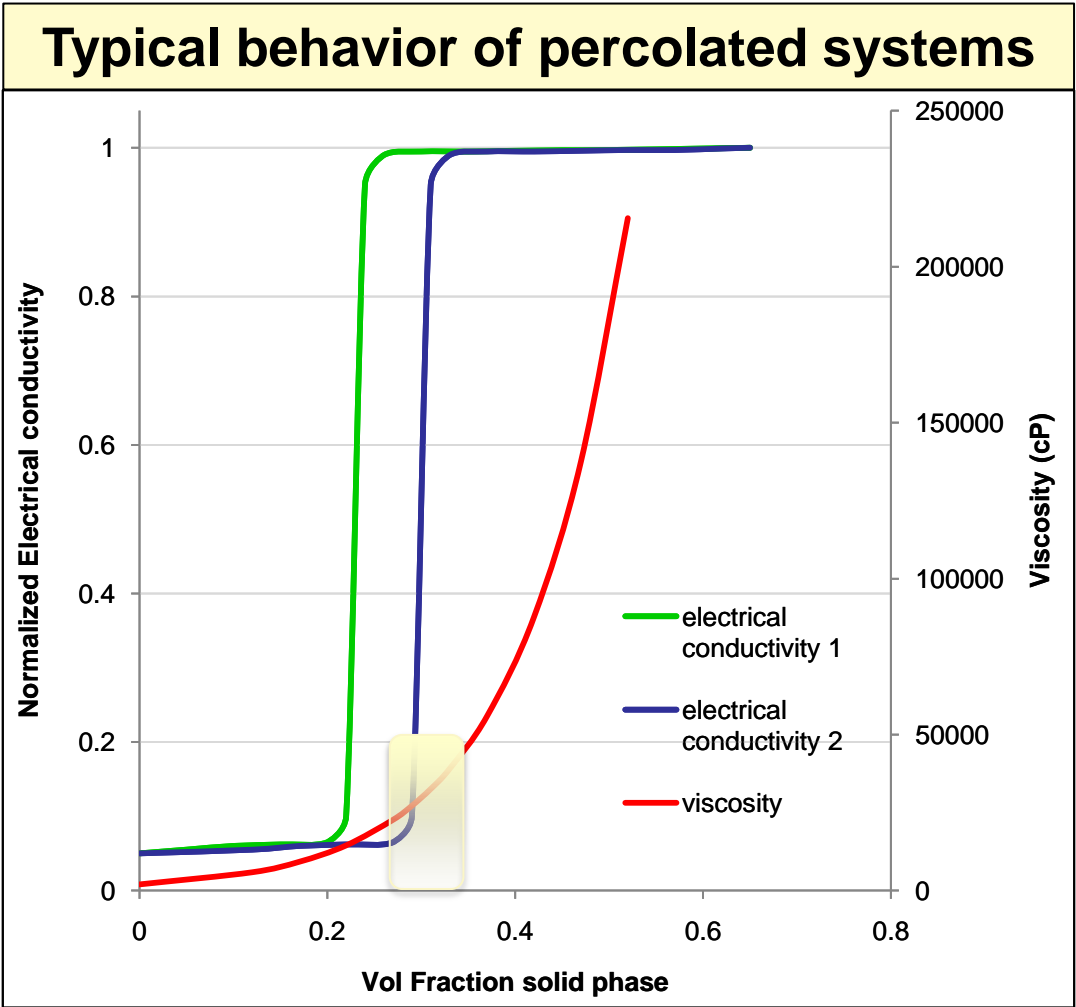
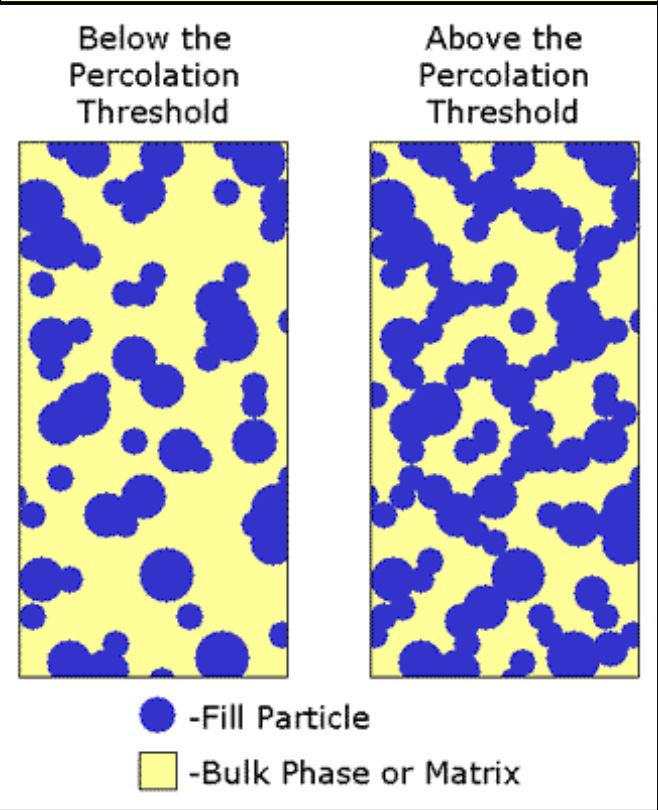


Kinetics of flow (model)



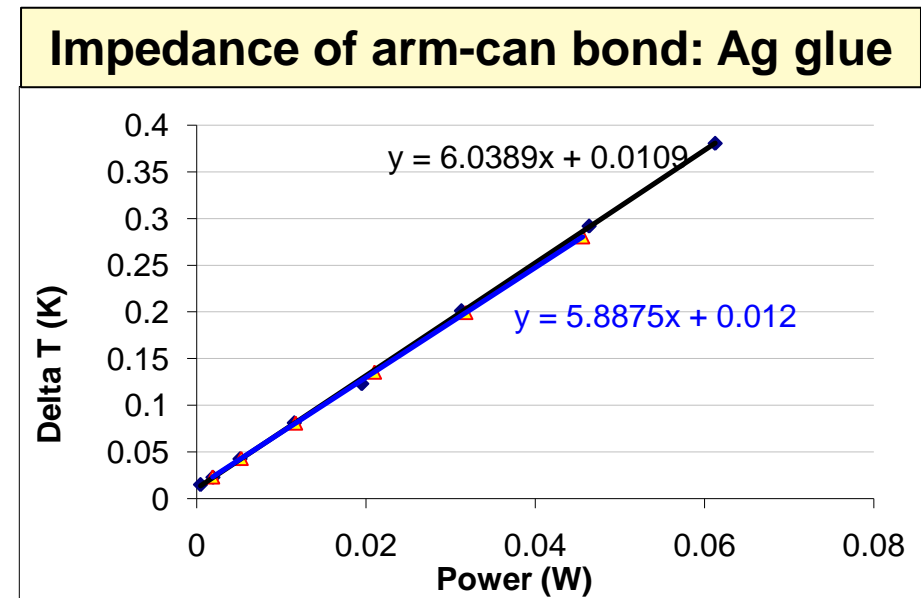
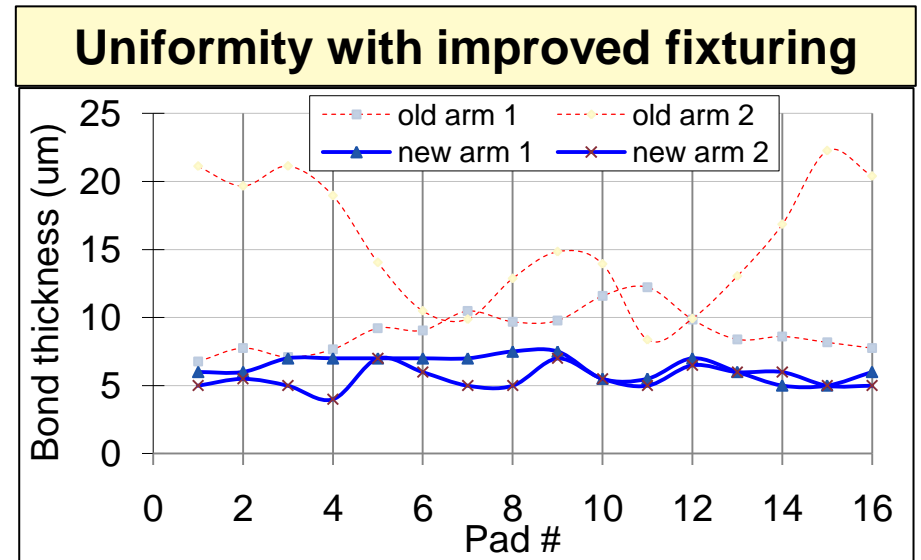
Composite adhesive- percolation

Percolation threshold is critical in filled systems



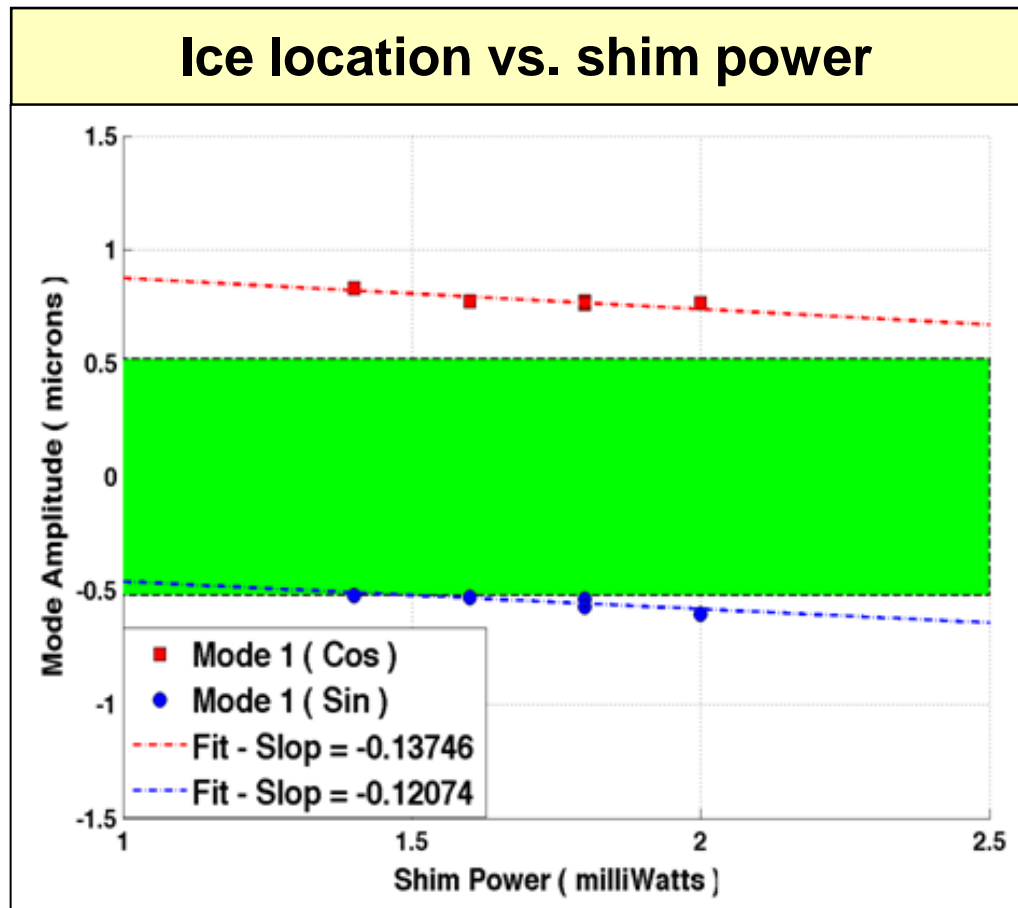
Thermal impedance of a TMP sub-assembly

- We used a silver filled adhesive that met these requirements:
 - ✓ Volume fraction - 35% (82wt%)
 - ✓ viscosity 3200 cP
 - ✓ particle size sub-micron
- Both critical parameters were optimized
 - Cryogenic thermal impedance of the filled adhesive
 - Bond thickness uniformity



Ice layer center has been sufficiently stable while shimming for all low mode specs

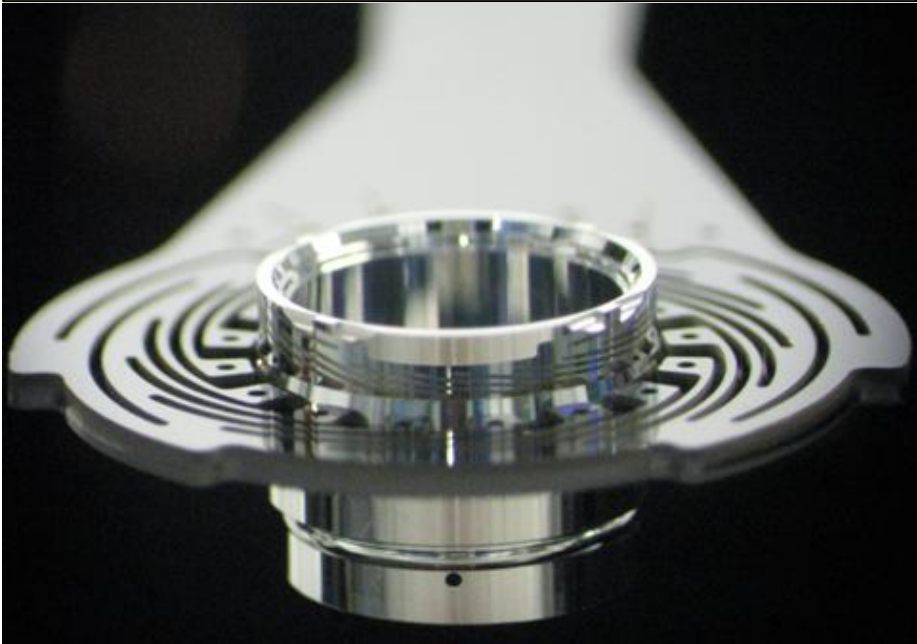
One more improvement was required- heat leak from leads to shim heaters



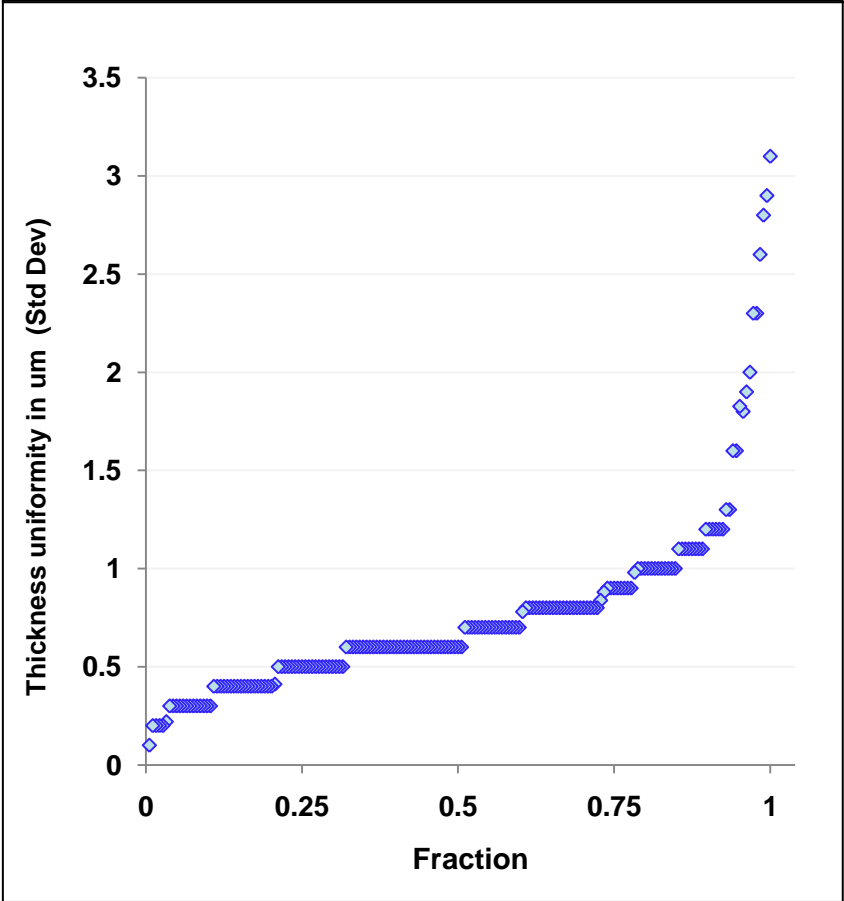
The remaining ~1 micron of ice position error due to capsule position. It can be adjusted with trim heaters if necessary

This approach was used in production of NIF targets

Can-Arm sub-assembly



Over 300 sub-assemblies

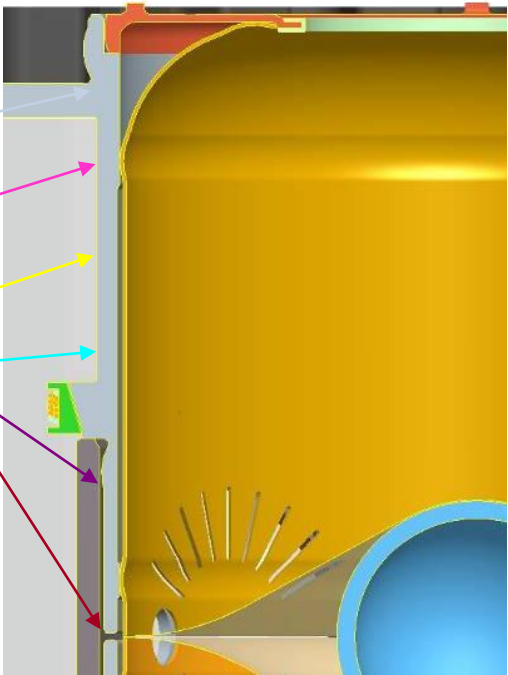
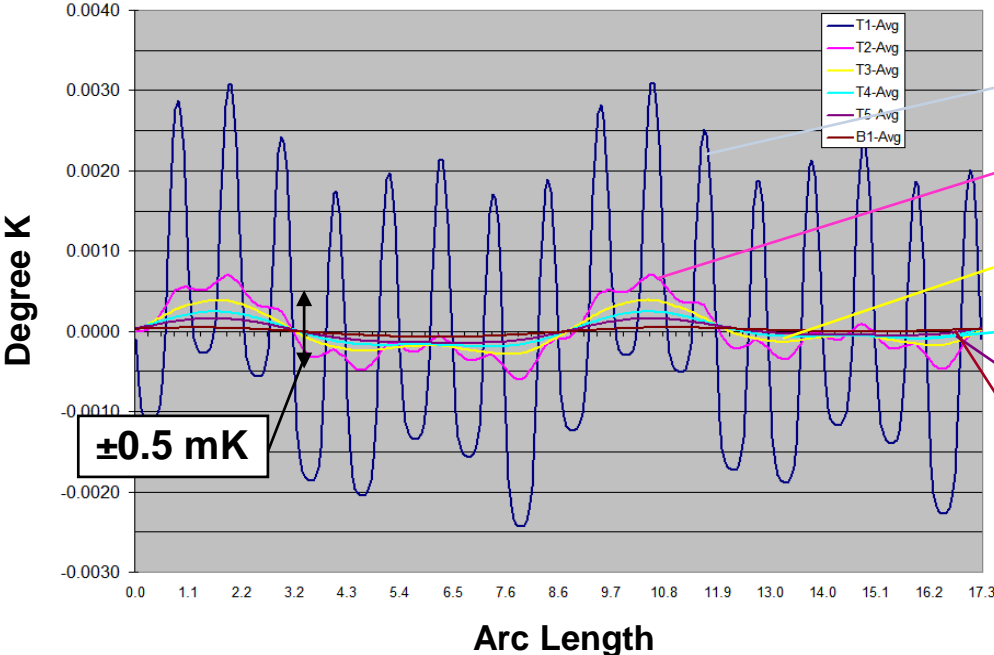


Statistics for controlling arm to can bond thickness have been excellent

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Thermal axisymmetry is critical



Signature of flexure (16x) attenuates in TMP